



# INSTYTUT TECHNOLOGII ELEKTRONOWEJ

Al. Lotników 32/46, 02-668 Warsaw, Poland

<http://www.ite.waw.pl>



**INNOWACYJNA  
GOSPODARKA**  
NARODOWA STRATEGIA SPÓJNOŚCI

**UNIA EUROPEJSKA**  
EUROPEJSKI FUNDUSZ  
ROZWOJU REGIONALNEGO



DKZ/73/2011

Warsaw, 07.07.2011.

**Re: The open procedure for delivery of the of the two Reflux baths for wet etching in KOH.**

With regard to the following questions:

*Is a hermetic chamber working under overpressure required ?*

we kindly inform that:

**No, a hermetic chamber is not required.**

Michał Urbański

Vice-Director for Administrative and Technicals Affairs

Director tel. +48 22 548 77 00; +48 22 843 30 93  
Deputy Director tel. +48 22 548 78 00  
Vice-Director for Research and Development tel. +48 22 548 77 60  
Vice-Director for Division of Silicon MNT, tel. +48 22 716 59 90  
Vice-Director for Division in Krakow tel. +48 12 656 51 83  
Chief Accounting Officer tel. +48 22 548 79 00

ISO 9001



Fax: +48 22 847 06 31  
NIP: 525-000-91-11

Bank Account:  
BRE Bank S.A., II Oddział Korporacyjny w Warszawie  
47 1140 1977 0000 5580 4500 1001